

Optical Properties of GaAsN Single Layers and GaAsN/InAs/GaAs Superlattices studied by Spectroscopic Ellipsometry (G6.35)

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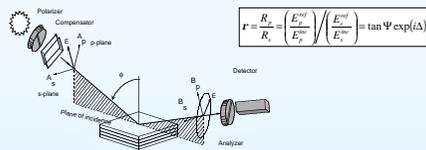
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Outline

- We present dielectric functions of GaAs_{1-y}N_y (0% ≤ y ≤ 3.7%) for wavenumbers from 100 cm⁻¹ to 600 cm⁻¹ and for photon energies from 0.75 eV to 4.5 eV.
- For 0.75 eV ≤ E ≤ 4.5 eV we compare our model dielectric functions (MDF) with wavelength by wavelength inverted ellipsometric data.
- We perform two critical point (CP) analysis for the band gap and the E₁ and E₁+Δ₁ transitions and calculate the effect of biaxial strain onto the latter.
- We analyse energy and amplitude of the GaN sublattice resonances in the GaAsN sublayers of our compressive and tensile strained superlattices.

Spectroscopic-Ellipsometry (SE)



$$r = \frac{R_p}{R_s} = \frac{E_{p,r}^m}{E_{p,i}^m} \left/ \frac{E_{s,r}^m}{E_{s,i}^m} \right. = \tan \Psi \exp(i\Delta)$$

Samples

- MOVPE, T=525 C
- precursors: TMGa, TBAs, DMHy

Single Layers

oxide	2-3 nm
GaAs _{1-y} N _y	~350 nm
GaAs buffer	~300 nm
(001) Te-GaAs	~1 mm

Superlattices

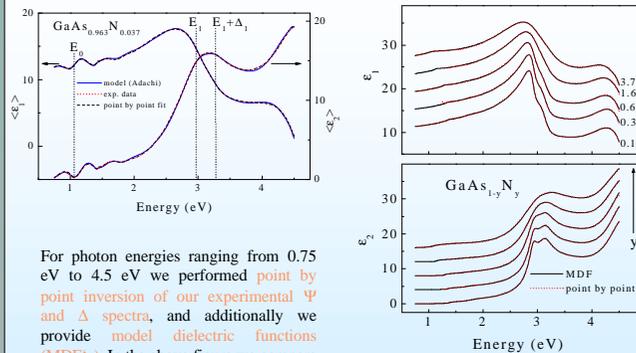
compressive

tensile

Layer	Thickness
oxide	2-3 nm
GaAs	18 nm
GaAs _{1-y} N _y	3 nm
InAs	0.3 nm
GaAs buffer	~500 nm
(001) Te-GaAs	~1 mm

Layer	Thickness
oxide	2-3 nm
GaAs cap	30 nm
GaAs _{1-y} N _y	8 nm
GaAs	9 nm
InAs	9 nm
GaAs buffer	~300 nm
(001) Te-GaAs	~1 mm

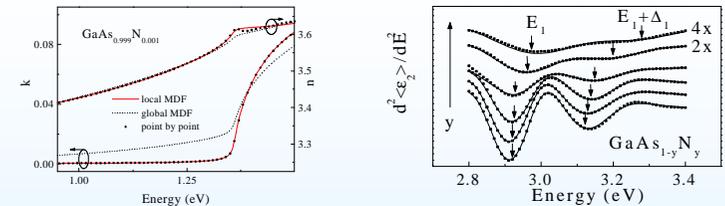
Modelling the dielectric function of GaAsN single layers for 0.75 eV ≤ E ≤ 4.5 eV



For photon energies ranging from 0.75 eV to 4.5 eV we performed **point by point inversion** of our experimental Ψ and Δ spectra, and additionally we provide **model dielectric functions (MDF's)**. In the above figure we compare the results of both analysis for sample GaAs_{0.963}N_{0.037}. The red dotted lines refer to the experimental pseudodielectric functions $\langle \epsilon \rangle$, and the blue straight (black dashed) lines to the best fit model (point by point) spectra. Notice the good agreement between all three spectra.

¹ S. Adachi, *Physical properties of III-V semiconductor compounds* (Wiley, New York, 1992).

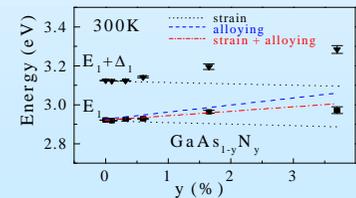
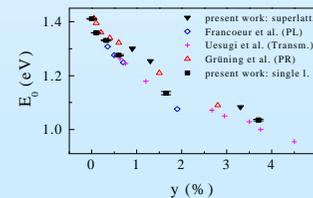
Critical point analysis for the E₀, E₁ and E₁+Δ₁ transitions



Our global model gives **too large absorption indices below the bandgap** (see Fig. above). That's why we employed a different (local) MDF for energies from 0.75 eV to 1.5 eV that agrees well with the point by point extracted optical constants.

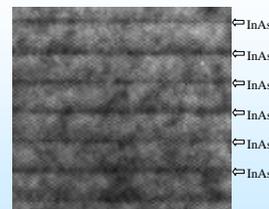
Local MDF

$$\epsilon_{loc}(E) = \epsilon_{Adachi}^{E_0}(E) + \epsilon_{Adachi}^{E_0+\Delta_0}(E) + \frac{A_{pole}}{E^2 - E_{pole}^2}$$



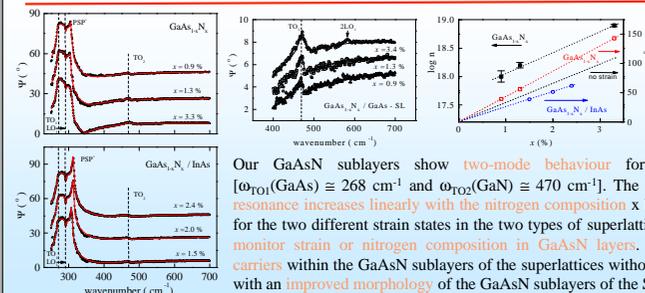
We employ **Adachi's critical-point composite model**¹ for parameterization of the GaAs_{1-y}N_y dielectric function ε(E) for photon energies ranging from 0.75 eV to 4.5 eV. Adachi's MDF is based on the **one-electron interband-transition approach**, and includes terms for the E₀, E₀+Δ₀, E₁, E₁+Δ₁ transitions, and phenomenological terms that describe contributions from higher-lying direct transitions.

TEM cross section of SL



TEM: Dr. G. Wagner @ Institut für Surface Modification Leipzig, Germany

GaN-sublattice resonance of superlattices



Our GaAsN sublayers show **two-mode behaviour** for infrared wavelengths [ω_{TO1}(GaAs) ≅ 268 cm⁻¹ and ω_{TO2}(GaN) ≅ 470 cm⁻¹]. The **amplitude f** of the GaN resonance increases linearly with the nitrogen composition x but with different slopes for the two different strain states in the two types of superlattices. This can be used to monitor strain or nitrogen composition in GaAsN layers. We further detect free carriers within the GaAsN sublayers of the superlattices without InAs. This goes along with an **improved morphology** of the GaAsN sublayers of the SL's with InAs.

$$f = (\omega_{LO2} - \omega_{TO2}) / \omega_{TO2}$$

n ... carrier conc.

Dielectric function from far-IR to UV

